



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 21, 2024

IGI Report Number  
Description  
Shape and Cutting Style  
Measurements

LG653426680  
LABORATORY GROWN DIAMOND  
CUT CORNERED RECTANGULAR MODIFIED BRILLIANT  
8.53 X 6.28 X 4.21 MM

GRADING RESULTS

Carat Weight  
Color Grade  
Clarity Grade

1.89 CARAT  
F  
VS 2

ADDITIONAL GRADING INFORMATION

Polish  
Symmetry  
Fluorescence

EXCELLENT  
EXCELLENT  
NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

IGI LG653426680

LABORATORY GROWN DIAMOND REPORT

September 21, 2024

IGI Report No LG653426680

CUT CORNERED RECT. MODIFIED BRILLIANT

8.53 X 6.28 X 4.21 MM

Carat Weight  
Color Grade  
Clarity Grade

1.89 CARAT  
F  
VS 2

Depth  
Table  
Girdle

67%  
64%  
Medium

Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG653426680

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

LG653426680

Report verification at igi.org

PROPORTIONS

Medium

13%  
51%  
64%  
67%  
Pointed

Sample Image Used

IGI LG653426680

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

www.igi.org

© IGI 2020, International Gemological Institute

FD - 10 20

IGI

September 21, 2024

IGI Report No LG653426680

CUT CORNERED RECT. MODIFIED BRILLIANT

8.53 X 6.28 X 4.21 MM

Carat Weight  
Color Grade  
Clarity Grade

1.89 CARAT  
F  
VS 2

Depth  
Table  
Girdle

67%  
64%  
Medium

Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG653426680

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa